



00862.022516.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Ryo TAKAI et al. ) : Examiner: M. A. Lyons  
Application No.: 10/073,593 ) : Group Art Unit: 2877  
Filed: February 12, 2002 ) : Confirmation No. 4328  
For: EXPOSURE APPARATUS INCLUDING ) : Allowed: February 27, 2004  
INTERFEROMETER SYSTEM ) : May 13, 2004

**Mail Stop RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statements filed on April 30, 2002, and March 1, 2004, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form and to the copending application discussed below. A copy of the listed document is also enclosed.

Japanese patent document number 8-241849 discloses a structure which includes an interferometer disposed on a stage and a mirror disposed on a lens barrel.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.



O I P E  
MAY 13 2004  
S C B S  
U. S. P A T E N T  
T R A D E M A R K  
O F F I C E

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) May 13, 2004			ATTY DOCKET NO. 00862.022516		APPLICATION NO. 10/073,593		
			APPLICANT Ryo TAKAI et al.				
			FILING DATE February 12, 2002			GROUP 2877	
			U.S. PATENT DOCUMENTS				
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		8-241849	09/17/1996	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER			DATE CONSIDERED				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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